



JAN
2007

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Group Art Unit: 1762

Application No.: 10/827,317

Examiner: J. LIN

Filed: April 20, 2004

Docket No.: 119294

For: PATTERN FORMATION METHOD, DEVICE MANUFACTURING METHOD,
ELECTRO-OPTICAL DEVICE, AND ELECTRONIC APPARATUS

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 22, 2007 Office Action, reconsideration of the rejections is respectfully requested in light of the following remarks.